## JGEPI AGENȚIA DE STAT PENTRU PROPRIETATEA INTELECTUALĂ



Expoziția Internațională Specializată INFOINVENT

Ediția a XVIII-a, 22-24 Noiembrie 2023



## CONTACTLESS STRAIN MEASUREMENT SENSOR BASED ON AMORPHOUS FERROMAGNETIC MICROWIRES

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Goal:

The invention relates to the measurement technique, in particular extensometry, and can be used to measure the deformations of solid bodies subjected to stretching, including irreversible ones, for example critical residual deformations in pressure vessels, in particular in high-pressure composite cylinders. Patent application, a 2022 0020, of 30.06.2023

Solution:

Non-contact measurement of the deformation of solid bodies and reduction of restrictions on the distance/positioning of excitation-detection coils from the sensitive element of the sensor by detection-analysis of the change in magnetic characteristics of materials subjected to mechanical stresses.

**Advantages:** reducing the dependence of measurement results on the positioning of the detection device relative to the sensitive element of the sensor; ✓ increasing the distance of reliable deformation detection; reduction of measurement errors by compensating the dependence on the ambient temperature; ✓ increased stress sensitivity. Stage: The hysteresis cycle during the Laboratory tests. remagnetization of two microwires 1500 B The sequence of response pulses to the remagnetization of two microwires 10002000 V 1500 500 1000 Η 500 -1500 -1000 -500 500 1000 1500 0 3348 500 10045 1674 5022 6696 8371 1719 13393 -500 ٬۰۰۰. -IUUU -1000 -1500 -1500 -2000 Hysteresis loop area of a reference

> Dependence of the area of the hysteresis loop on the deformation of the sensitive wire



The parameters of reference microwire do not depend on the deformation. Comparing the magnetic characteristics of the hysteresis loops, the magnitude of deformation is determined. The sensor can be applied in conditionbased monitoring of bodies/equipment subjected to mechanical stress.

## wire as a function of temperature



The contactless strain sensor consists of at least two segments of amorphous ferromagnetic microwires – a sensitive wire and at least one reference wire, mounted on a solid body. When an alternating magnetic field is applied, the sensor responds with impulses induced at the remagnetization. The hysteresis loop and coercive force of sensitive microwire with high positive magnetostriction increase with tensile strain.



The work was developed within the PS Project no: 20.80009.5007.08.

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